Docket No.

219723US2S

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hajime NAGANO et al.

SERIAL NO: 10/078,344

GAU: 2814

FILED:

February 21, 2002

EXAMINER: NGO, N. V.

FOR:

SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND MANUFACTURING

METHOD THEREOF

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

It is hereby requested that a three month extension of time be granted to February 8, 2004 for			
	filing a response to the Official Action dated:		
	responding to the requirements in the Notice of Allowability dated:		
	filing the Formal Drawings. The Issue Fee due has been timely filed.		
	responding to the Notice to File Missing Parts of Application dated:		
	filing a Notice of Appeal. A timely response to the final rejection, due November 8, 2003 has been filed.		
	filing an Appeal Brief. A Notice of Appeal was filed on:		
	Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.		
The required fee of \$950.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. <u>15-0030</u> . A duplicate copy of this sheet is enclosed.			

02/10/2004 SSANDARA 00000002 10078344

02 FC:1401

330.00 DP

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAJER & NEUSTADT, P.C.

Customer Number

22850

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

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Eckhard H. Kuesters

Registration No. 28,870